PATENT Docket No. 150.00810102 IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 2823 Group Art Unit: Applicant(s): Vaartstra G. Fourson III Examiner: 09/865,612 May 25, 2001 METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-CONTAINING FILMS ON SEMICONDUCTOR STRUCTURES

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENTX RECEIVED

Assistant Commissioner for Patents Washington D.C. 20231

FEB 2 8 2003

**TECHNOLOGY CENTER 2800** 

Sir:

Serial No.:

Filed:

For:

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with C.F.R. §§ 1.97 et. seq., the materials enclosed herewith are brought to the attention of the Examiner as possibly being of interest in connection with the above-identified patent application. Per M.P.E.P. § 609, the information cited in the present Information Disclosure Statement shall not be construed to be an admission that the information is, or is considered to be, material to patentability. Consideration of each of the documents listed on the attached 1449 form(s) is respectfully requested. Pursuant to the provisions of M.P.E.P. §609, Applicant further requests that a copy of the 1449 form(s), marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

Since this Information Disclosure Statement is submitted after the receipt of an Office Action in the above-identified patent application, please charge Deposit Account No. 13-4895 in the amount of \$180 under 37 C.F.R. §§1.97(c) and 1.17(p), any additional fees, or credit any overpayment.

Page 2

Supplemental Information Disclosure Statement

Serial No. 09/865,612

Filed: May 25, 2001 METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-CONTAINING FILMS ON

SEMICONDUCTOR STRUCTURES

The Examiner is invited to contact Applicant's' Representatives at the below-listed telephone number, if they can be of any assistance during prosecution of the present application.

CERTIFICATE UNDER 37 C.F.R. 1.8:

The undersigned hereby certifies that this paper is being transmitted by facsimile in accordance with 37 CFR §1.6(d) to the Patent and Trademark Office, addressed to Assistant Commissioner for Patents, Washington, D.C. 20231, on this day of February, 2003, at (Central Time)

Pelsony 28, 200

Date

Respectfully submitted,

Vaartstra

By his Representatives, Mueting, Raasch & Gebhardt, P.A.

P.O. Box 581415 FAX RECEIVED

Minneapolis, MN 55458-1415

(612)305-1220

FEB 2 8 2003

**TECHNOLOGY CENTER 2800** 

Loren D. Albin

Reg. No. 37,763

Direct Dial (612)305-1225